



Docket No.: 202450US0/sal

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Atsushi SHIOTA, et al.

SERIAL NUMBER: 09/770,289

GROUP: 1712

FILED: January 29, 2001

EXAMINER: FEELY, MICHAEL J

FOR: PROCESS FOR PRODUCING SILICA-BASED FILM, SILICA-BASED FILM, INSULATING FILM, AND SEMICONDUCTOR DEVICE

LETTER

MAIL STOP ISSUE FEE
COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

SIR:

In the matter of the above-identified application, please note that no foreign priority is being claimed.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.
Norman F. Oblon



Corwin P. Umbach, Ph.D.

Registration No. 40,211

Joseph Scafetta, Jr.

Registration No. 26,803

Customer Number

22850

Tel. (703) 413-3000
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(OSMMN 05/04)

DOCKET NO.: 202450US0/sal



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Atsushi SHIOTA, et al.

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FOR: PROCESS FOR PRODUCING SILICA-BASED FILM, SILICA-BASED FILM, INSULATING FILM, AND SEMICONDUCTOR DEVICE

**APPLICATION OF PREVIOUSLY PAID ISSUE FEE IN
ACCORDANCE WITH SECTION 1308.01 MPEP**

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The above-identified application was withdrawn from Issue after payment of the Issue Fee in the amount of \$1610 (Issue Fee \$1280.00 + Pub. Fee \$300.00 + Adv. Patent Copies \$30.00). Enclosed is a credit card form in the amount of \$90.00 to include the increase in the Issue Fee.

The application has now been allowed again and since a refund of the previously paid Issue Fee has not been requested, it is now requested that the previously paid Issue Fee be applied to the Issue Fee being paid herewith. Enclosed herewith is copy of the Notice of Withdrawal from Issue.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.
Norman F. Oblon


Corwin P. Umbach, Ph.D.
Registration No. 40,211

Joseph Scafetta, Jr.
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JC98
UNITED STATES PATENT AND TRADEMARK OFFICE

202450US0

UNITED STATES PATENT and TRADEMARK OFFICE

UNDER SECRETARY OF COMMERCE FOR INTELLECTUAL PROPERTY AND
DIRECTOR OF THE UNITED STATES PATENT AND TRADEMARK OFFICE
WASHINGTON, D.C. 20231
WWW.USPTO.GOV

NOV 27 2004

#12

In re Application of :
Atsushi Shiota, et al. :
Serial No. 09/770,289 :
Filed: January 29, 2001 :
For: PROCESS FOR PRODUCING :
SILICA-BASED FILM, SILICA-BASED :
FILM, INSULATING FILM, AND SEMI- :
CONDUCTOR DEVICE :
NOTICE OF WITHDRAWAL
FROM ISSUE UNDER
37 CFR 1.313 (b)

The above-identified application is withdrawn from issue after payment of the issue fee due to: reopening of prosecution. See 37 CFR 1.31(b).

The above-identified application is hereby withdrawn from issue.

The issue fee is refundable upon written request. If, however, the application is again found allowable, the issue fee can be applied toward payment of the issue fee in the amount identified on the new Notice of Allowance and Issue Fee Due upon request. This request and any balance due must be received on or before the due date noted in the new Notice of Allowance in order to prevent abandonment of the application.

Telephone inquiries should be directed to Robert Dawson at (703) 306-2340.

The above-identified application is being forwarded to the examiner for prompt appropriate action, including applicant of the new status of this application.

Richard V. Fisher

Richard V. Fisher, Director
Technology Center 1700
Chemical and Materials Engineering

RECEIVED:
12/2/02
OBLOV, SPIVAK, McCLELLAND
MAIER & NEUSTADT, P.C.

DOCKETING DEPT

Initials/Date Docketed: *A3H 12/2/02*

Type of Resp(s):

Date Date(s):

CCOPY

09/770,289

-2-

Oblon, Spivak, McClelland Maier
& Neustadt PC
Fourth Floor
1755 Jefferson Davis Highway
Arlington, VA 22202

Cc: Allowed Files-PK3-910

CCPY